



1763

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SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1763
Maximilian A. Biberger *et al.*) Examiner: Ram N. Kacker
Serial No.: 09/912,844) **TRANSMITTAL LETTER**
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Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

Enclosed please find Amendment and Response to Office Action Mailed on November 13, 2002 for filing with the U.S. Patent and Trademark Office.

The Commissioner is authorized to charge any additional fee or credit any overpayment to our Deposit Account No. 08-1275. An originally executed duplicate of this transmittal is enclosed for this purpose.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: February 12, 2003

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CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

- 1 -

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